

<p>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</p> <p>(Use several sheets if necessary)</p> <p>PTO Form 1449</p>	Atty Docket No.	Application No.
	113197-010	09/857,912
	Applicant	
	Iijima, Y., et al.	
	Filing Date	Group
	June 11, 2001	1751

857,912

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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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Examiner's Initials	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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Examiner: <u>Colleen P. Cooke</u>	Date Considered: <u>5/1/03</u>
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113197-010

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Unknown

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Ichinose, A., et al., "Deposition of Y2O3 buffer layers on biaxially-textured metal substrates," *Physica C Superconductivity*, Vol. 302 (1998) No. 1, June 10, 1998, pp. 51-56.

Allen V. Cooke

S/1/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.